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ABSTRACT OF THE DISCLOSURE

METHOD FOR MANUFACTURING THIN-FILM MAGNETIC HEAD AND MANUFACTURING SYSTEM OF THE HEAD

A method for manufacturing a thin-film magnetic head includes a step of cutting a wafer into bars, each bar having a plurality of thin-film magnetic head sliders which are sequentially coupled with each other, a step of identifying the bar to be worked to generate an identification signal which indicates identity of the bar, a step of obtaining data of the bar in a unit of bar depending upon the identification signal, and a step of processing at least one working of the bar on the basis of the obtained data of the bar.

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